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In re Application of
Selvamanickam
Serial Number: 10/602,467
Filed: June 23, 2003
For: APPARATUS FOR HIGH-THROUGHPUT ION
BEAM-ASSISTED DEPOSITION (IBAD)

PETITION UNDER
M.P.E.P.708.02 IX

This is in response to the petition filed February 12, 2004, requesting that the above-identified application be granted Special Status under Section 708.02 IX of the MPEP and 37 CFR 1.102 (b) (**no fee required**).

The request for Special Status considered under Section 708.02 IX of the MPEP is granted because criteria under 37 CFR 1.102(b) has been met.

Accordingly the petition is **GRANTED**.

Marian C. Knod
Marian C. Knod, Special Programs Examiner
Technology Center 1700
Chemical and Materials Engineering

Serle Mosoff
KATTEN MUCHIN ZAVIS ROSENMAN
575 MADISON AVENUE
NEW YORK NY 10022-2585